Refine Search

for 10/685,588

Search Results -

Terms	Documents
(ebr or (bevel adj edge)) same (cmp or polish$4 or clean$4 or remov$3) same wafer	192

Database:

US Pre-Grant Publication Full-Text Database
US Patents Full-Text Database
US OCR Full-Text Database
EPO Abstracts Database
JPO Abstracts Database
Derwent World Patents Index
IBM Technical Disclosure Bulletins

Search: L1

[Refine Search]

[Recall Text ⬍]   [Clear]   [Interrupt]

Search History

DATE: Thursday, March 17, 2005   Printable Copy   Create Case

Set Name side by side	Query	Hit Count	Set Name result set
	DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ		
L1	(ebr or (bevel adj edge)) same (cmp or polish$4 or clean$4 or remov$3) same wafer	192	L1

END OF SEARCH HISTORY